

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No.: 2015
Koichiro TANAKA et al.)	Examiner: Abdulfattah Mustapha
Serial No. 10/582,614)	Group Art Unit: 2812
Filed: June 12, 2006)	
For: LASER IRRADIATION METHOD,)	
LASER IRRADIATION APPARATUS,)	
AND METHOD FOR)	
MANUFACTURING)	
SEMICONDUCTOR DEVICE)	


SUBMISSION OF PUBLICATION FEE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the *Notice of Allowance and Fee(s) Due* dated December 15, 2009, enclosed is the Publication Fee in the amount of \$300.00.

Respectfully submitted,



Eric J. Robinson
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